

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|---|------------------|---------|------------------|
| S1 | 455 | oxide and (chamber same cleaning) and halogen and chamber adj walls | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/03 11:47 |
| S2 | 136 | load adj lock and S1 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/03 12:49 |
| S3 | 2 | ("6066519").PN. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/03/03 12:11 |
| S4 | 455 | oxide and (chamber same cleaning) and halogen and chamber adj walls | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/03 14:00 |
| S5 | 7 | load adj lock and S4 and second adj temperature | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/03 12:50 |
| S6 | 28 | implanting near4 room adj temperature | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/03 13:35 |
| S7 | 27 | cluster adj tool and mosfet and room adj temperature | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/03 13:35 |
| S8 | 281 | oxide and (chamber same cleaning) and halogen and chamber adj walls and ceramic | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/03 14:31 |

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|-----|--------|---|---|----|----|------------------|
| S9 | 415396 | oxide same temperature | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/03 14:31 |
| S10 | 156 | S8 and S9 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/04 10:17 |
| S11 | 84575 | temperature near5 oxide | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/03 14:32 |
| S12 | 76 | S10 and S11 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/03 14:32 |
| S13 | 5 | ("5186718" "5254176" "5286296" "5308431" "5380370").PN. | US-PGPUB; USPAT; USOCR | OR | ON | 2005/03/04 09:58 |
| S14 | 363226 | heater and "5" | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/04 09:58 |
| S15 | 2 | heater and S13 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/04 09:59 |
| S16 | 26 | substrate adj heater near4 embedded | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/04 09:59 |
| S17 | 281 | oxide and (chamber same cleaning) and halogen and chamber adj walls and ceramic | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/04 10:17 |

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|-----|--------|---|---|----|----|------------------|
| S18 | 415591 | oxide same temperature | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/04 10:17 |
| S19 | 156 | S17 and S18 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/04 10:18 |
| S20 | 17 | teos and (psg or phosphorus adj doped glass) and S19 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/04 10:18 |